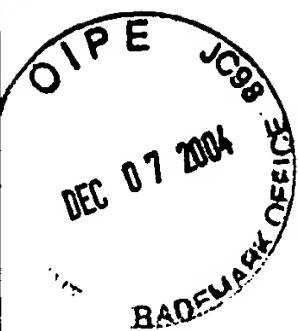


IFW



00862.022170

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Haruhito ONO et al.) : Examiner: D. A. Vanore
Application No.: 09/819,907) : Group Art Unit: 2881
Filed: March 29, 2001) : Confirmation No.: 5369
For: ELECTRON OPTICAL SYSTEM,) : Allowed: November 19, 2004
CHARGED-PARTICLE BEAM EXPOSURE : December 7, 2004
APPARATUS USING THE SAME, AND)
DEVICE MANUFACTURING METHOD :

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

LETTER REQUESTING CONSIDERATION
OF PAPERS TIMELY FILED

Sir:


Applicants have received a Notice of Allowance and a Notice of Allowability dated November 19, 2004, in the above-identified application. Applicants, however, filed a Third Supplemental Information Disclosure Statement on August 7, 2003, prior to issuance of the Notice of Allowance on November 19, 2004. To date, the Examiner has not yet indicated consideration of those papers. Accordingly, Applicants request that the Examiner indicate consideration of the material submitted in that Information Disclosure Statement by initialing and returning a copy of the PTO-1449 form attached to that paper. Attached, for the Examiner's convenience, are copies of the Third Supplemental Information

Disclosure Statement, the PTO-1449 form, and the U.S. Patent and Trademark Office date stamped postcard receipt indicating the filing of those papers on that date.

Applicants believe that no fees should be incurred in connection with filing this paper. However, the Commissioner is authorized to charge Deposit Account No. 06-1205, should any fees be associated herewith. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

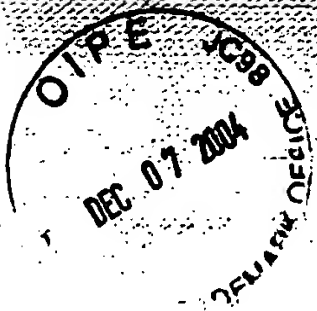
Respectfully submitted,


Attorney for Applicants
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



Date 08 / 07 / 2003
Mo. Day Yr.
Atty. Docket 05862-022170
Application 09/819,907

Sir:

Kindly acknowledge receipt of the accompanying:

- ☐ Response to Official Action. _____
- ☐ Check for \$ _____ (claims fee)
- ☐ Petition under 37 CFR 1.136 and Check for \$ _____
- ☐ Notice of Appeal and Check for \$ _____
- ☒ Information Disclosure Statement, PTO-1449 and SIX (6) documents
- ☐ Claim for priority and certified copies of _____ priority applications
- ☐ Issue fee transmittal and Check for \$ _____
- ☐ Other (specify) _____

by placing your receiving date stamp hereon and returning to deliverer.

Atty. SAW/ESB

Due Date _____
Mo. Day Yr.

FOHS-D-00



00862.022170

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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APPARATUS USING THE SAME, AND)	
DEVICE MANUFACTURING METHOD)	

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED NOTICE OF ALLOWANCE

Sir:

Applicants have received a Notice of Allowance and a Notice of Allowability dated November 19, 2004, in the above-identified application, in which the Notice of Allowance lists the TITLE OF INVENTION as "ELECTRON OPTICAL SYSTEM, CHARGED-PARTICLE BEAM EXPOSURE APPARATUS USING THE SAME, AND DEVI MANUFACTURING METHOD."


The title as listed contains a misspelled word. Specifically, the thirteenth word "DEVI" should read -- DEVICE --. Applicants, therefore, request that the TITLE OF THE INVENTION be corrected to read -- ELECTRON OPTICAL SYSTEM, CHARGED-PARTICLE BEAM EXPOSURE APPARATUS USING THE SAME, AND **DEVICE** MANUFACTURING

METHOD --. Accordingly, Applicants request that a corrected Notice of Allowance be issued to make this correction.

Applicants believe that no fees should be incurred in connection with filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be associated therewith. A duplicate of this document is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our below-listed address.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
Registration No. 33,326

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